

**Search Notes**

Application/Control No.

10/826,267

Examiner

David Y. Chung

Applicant(s)/Patent under  
Reexamination

KIM ET AL.

Art Unit

2871


**SEARCHED**

Class	Subclass	Date	Examiner
349	129	2/21/2005	DC
349	130	2/21/2005	DC
349	122	2/21/2005	DC
349	138	2/21/2005	DC
349	139	2/21/2005	DC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	2/21/2005	DC
Consulted Ken Parker regarding allowable subject matter 	2/21/2005	DC